



Docket No.: M4065.0383/P383-C
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Kie Y. Ahn et al.

Allowed: May 18, 2005

Application No.: 10/759,079

Confirmation No.: 7174

Filed: January 20, 2004

Art Unit: 2818

For: LOW-LOSS COPLANAR
WAVEGUIDES AND METHOD OF
FABRICATION

Examiner: D. Nhu

**COMMENTS ON EXAMINER'S STATEMENT OF REASONS FOR
ALLOWANCE**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

While Applicants do not disagree with the Examiner's stated reasons for allowance, Applicants note that the allowed claims define further unique combinations of limitations not found in the prior art. Therefore, the stated reasons for allowance should be interpreted as highlighting only some of the reasons why the claims are allowable.

As usual, the scope of the claims should interpreted based on the actual language of the allowed claims, and no further limitation of the claims should be inferred from the Examiner's Statement of Reasons For Allowance.

Dated: August 18, 2005

Respectfully submitted,

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